Automatic Adjustment of Integration Time in the NIR Camera for Calibrated Temperature Measurement during Inductive Heating Processes

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Abstract

The system presented is based on a *Near Infrared Radiation (NIR)* camera. The *CCD* camera selected absorbs a small portion of radiation in the near infrared range, above λ = 700 nm. In addition, by using an *NIR* filter one can cut off the visible light to reduce noise and unwanted radiation. The system has been developed at the Institute of Applied Computer Science, Lodz University of Technology. This system has been made for controlling industrial thermal processes during the inductive heating hardening. The varying of camera integration time has been applied to avoid the saturation and to increase the sensitivity at a low temperature. The emissivity of the inductive heating object has been taken into account. New algorithms for temperature calibration and image processing have been developed enabling the measurement of temperatures from 250°C, thanks to the application of automatic adjustment of integration time.

1. Introduction

Using a *Near Infrared Radiation* spectral range to measure high temperatures is known in the literature [1-4]. High temperature object monitoring is the main application of such systems, e.g. in metallurgy [5], inductive heating [2] or for high temperature industrial processes [6]. Among many existing solutions using an *NIR* spectral range to measure high temperature objects, both monochrome and colour *CCD* camera-based systems are discussed [1,2]. All of them use a fixed integration time of the sensor. The previous systems allow the measurement of temperatures above 500°C. In addition, the emissivity is not always taken into account. Some of them use a concept of multispectral radiation measurement [5].

The novel method of the calibration of a *CCD-NIR* camera is presented in this paper. The novelty of this method consists in automatic correction of the camera signal according to the integration time that is adjusted to the intensity of incoming radiation in the *NIR* spectrum. The approximation of the calibration curve by the exponential function was proposed and verified experimentally. The examples of the temperature measurements both in static and dynamic thermal processes are presented in this paper. The emissivity was consideration into account during calibration and measurement.

2. CCD-NIR system with automatic adjustment of integration time

The system presented is based on a broadband high-sensitivity 12-bit monochrome *CCD* camera. The camera is equipped with an *NIR* interferential filter that cuts off the visible range – fig. 1. The spectral range of radiation absorption covers both *VIS* and *NIR* wavelength ranges up to 1000 nm – fig. 2. Special software was developed to vary the integration time according to the incoming light intensity. This means that at the beginning of heating, the high integration time is applied, while at the end of the temperature rise, the integration time is reduced to avoid the signal saturation. The spectral characteristics of the camera and the *NIR* filter are presented in fig. 2.

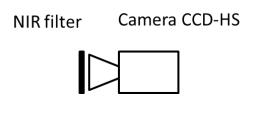




Fig. 1. High sensitivity CCD-HS with NIR filter

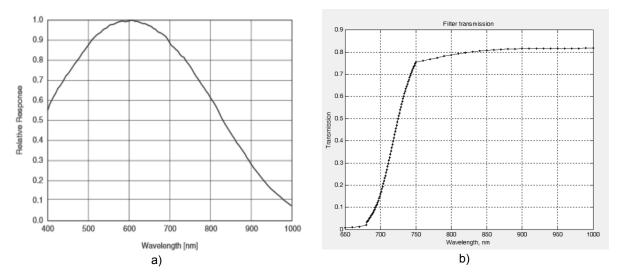


Fig. 2. Spectral characteristics of a CCD of high sensitivity (a) and an NIR filter (b)

Considering a large range of changes in radiation intensity and a high sensitivity of the *CCD* camera, software for the registration of images with variable integration time t_{int} was developed. To eliminate the effect of a change of integration time on the value of the digital signal DL (*Digital Level*) of the camera, i.e. to ensure the consistency of the DL/tint ratio, correction of the digital value of the signal generated by the camera (*DL_{cam}*) was introduced based on the following relationship:

$$DL = DL_{cam} \frac{10^6}{t_{int}} \tag{1}$$

where the integration time t_{int} is expressed in μ s. The maximum integration time of the camera used in the investigations was 1s (10⁶ μ s).

To confirm the correctness of use of relationship (1), a simple experiment was made. For a selected temperature of the object, a camera signal was determined at different integration times. The results are presented in Table 1.

Table 1. CCD-NIR camera signal for different integration times

<i>t_{int}</i> ,μs	500= t _{int0}	600	700	800	900	1000	1100	1200
DL	1625= <i>DL</i> 0	1963	2309	2695	3026	3327	3575	4015

A chart for DL/DL_0 = f(t_{int}/t_{int0}) was made. As expected, this function is nearly linear, which confirms the correctness of use of the relationship (1), i.e. obtaining DL/t_{int} = const – fig. 3. The values DL_0 = 1625 and t_{int0} = 500 µs denote the camera signal and integration time of the first measurement in Table 1.

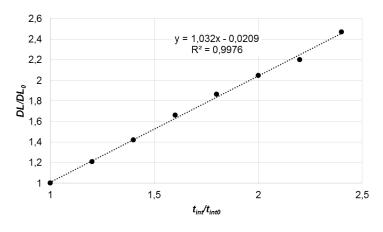


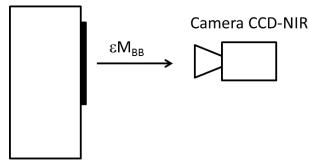
Fig. 3. Relationship DL/DL₀ = f(tint /tint₀)

3. Method of calibration of a CCD-NIR camera using a black body for the MWIR and LWIR ranges

Determination of emissivity of a calibration object

In the research a technical black body (calibration object) for spectral ranges *MWIR* (3-5 μ m) and *LWIR* (8-12 μ m) was used. Within these ranges the emissivity of a black body $\epsilon \approx 1$. Unfortunately, it is considerably lower for the *NIR* range. The aim of the research was to determine the emissivity of the calibration object for the *NIR* range of approximately 700-1000 nm. To this end a set of measurements was made.

Measurement 1 was carried out for different values of temperature of the calibration object in the range of $300-500^{\circ}$ C. The *CCD-NIR* camera signal was determined under darkened conditions (without background radiation) – fig. 4. It was assumed that in such conditions only the object radiates and its emissivity is ε .



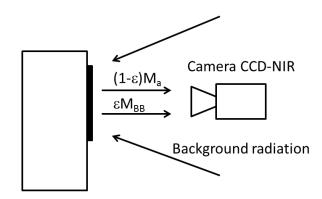
Black body for LWIR (100-500 °C)

Fig. 4. Measurement of radiation intensity of the calibration object in the NIR range in darkened conditions (DL_o)

The second measurement was made in laboratory light conditions (sunlight/interior light). A stronger signal of measurement of radiation intensity was obtained due to the reflected background radiation – fig. 5.

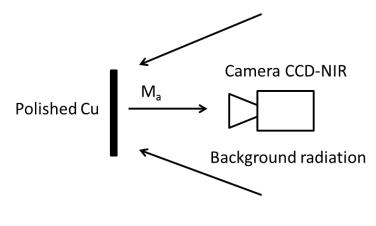
The third measurement dealt with background radiation. To this end, polished copper sheet was prepared which performed the function of a mirror in the *NIR* spectral range.

The background radiation intensity was measured and the measurement was made at room temperature $T_a=25^{\circ}C$ – fig. 6. To obtain the correct result of background radiation, the copper mirror must be placed in the same location as the reference object.



Black body for LWIR (100-500 °C)

Fig. 5. Measurement of radiation intensity of the calibration object in the NIR range in laboratory conditions (DL)



Ambient (25 °C)

Fig. 6. Measurement of radiation intensity of the background in the NIR range in laboratory conditions (DLa)

Basing on the measurement conditions presented in 4-6 the following relationships can be written (2)-(4).

$$\varepsilon M_{BB} = A * DL_o \tag{2}$$

$$(1 - \varepsilon)M_a + \varepsilon M_{BB} = A * DL \tag{3}$$

$$M_a = A * DL_a \tag{4}$$

where MBB denotes the spectral luminous exitance of a black body radiation in the NIR range, Ma – the background radiation exitance, *A* is the constant of the infrared camera.

Using equations (2)-(4) the emissivity of a calibration object can be determined, equations (5) and (6).

$$(1-\varepsilon)DL_a + DL_o = DL \tag{5}$$

$$\varepsilon = 1 - \frac{DL - DL_o}{DL_a} \tag{6}$$

The results of the emissivity measurement of the calibration object for different temperature values are presented in Table 2. As can be seen from Table 2 the black body for *MWIR* and *LWIR* is not a black body for the *NIR* range.

Temperature of the calibration object (°C)	Darkening (<i>DL</i> ₀)	Laboratory lighting (<i>DL</i>)	Reflection from the mirror (<i>DL</i> a)	Emissivity of the black body (<i>LWIR</i>)
250	26	662	11640	0.95
300	101	815	12904	0.94
350	684	1335	12264	0.95
400	3870	4525	12192	0.95
450	18130	18815	12360	0.94

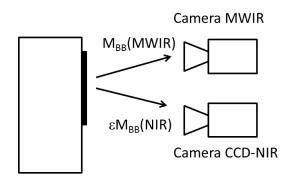
Table 2. Emissivity of the calibration object

Calibration of the CCD-NIR camera

The measurements were made in the absence of background radiation, in a dark room with the use of an *MWIR* (3-5 μ m) infrared camera. The experiment was carried out according to fig. 7. Two cameras operating in parallel were used: a *CCD-NIR* and an *MWIR* infrared camera. The emissivity of the calibration object for the *NIR* range was taken into account in the measurements. The calibration curve assumes the shape of a logarithmic function – fig. 8. When plotting the calibration curve, the conversion of digital values was taken into consideration according to the current value of the integration time according to relationship (1). Because of this conversion, the calibration curve does not depend on the integration time. The calibration curve was plotted based on areas of 16x16 pixels in the central section of images of both *NIR* and *MWIR* cameras. During the measurement, owing to the calibration curve determined one can calculate values of

10.21611/qirt.2016.149

temperature for each pixel of an image although due to the in-camera noise/proprietary noise of the camera, it is more appropriate to determine the temperature as a mean value for a number/several dozen of adjacent pixels.





Black body for LWIR (300-500 °C)

Fig. 7. Stand for the CCD-NIR camera calibration

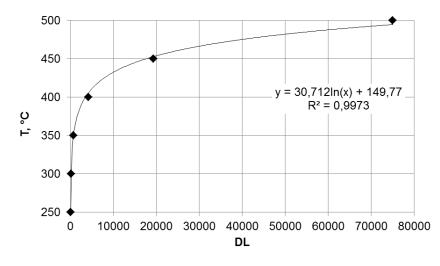


Fig. 8. Calibration curve for a range of 250-500°C

4. Measurement of temperature of an object of the emissivity ϵ

Prior to measuring temperature, the emissivity of the object under study in the *NIR* range should be determined. This is done at room temperature for which the object's own radiation in the *NIR* range can be neglected. Two measurements must be made. The first one aims at determining the intensity of radiation reflected from the object of the emissivity ε in the lighting conditions that will prevail during temperature measurement. As a result, the radiation intensity *DL* is obtained. Then, the background radiation DL_a is measured by means of a copper mirror – fig. 6. A very important parameter of this measurement is the positioning of the mirror in the place of the object studied (right in front of it) so that the mirror will reflect the same radiation as the object under study during the temperature measurement.

Equations (7) and (8) hold true for this experiment:

$$(1-\varepsilon)DL_a = DL_{\varepsilon} \tag{7}$$

$$\varepsilon = 1 - \frac{DL_{\varepsilon}}{DL_{\varepsilon}} \tag{8}$$

Once the object emissivity value is determined, we proceed to the proper measurement of the temperature value. This is done in the same conditions in which the emissivity was previously determined. We determine the object radiation intensity value DL_o based on the measurement of intensity DL under conditions of lighting of the object by background radiation – equation (9).

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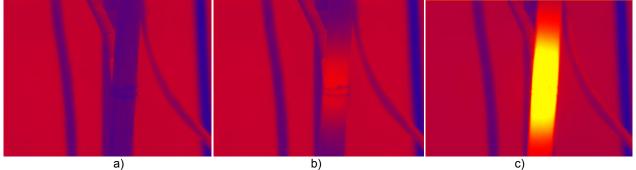
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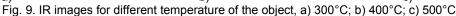
$$(1 - \varepsilon)DL_a + \varepsilon DL_a = DL \tag{9}$$

The measurement can be performed under darkened conditions. Then, the value of the background radiation should be assumed as $DL_a=0$. In such a case, the object radiation $DL_o=DL/\varepsilon$. Knowing the value DL_o of the object, we apply the previously determined calibration curve for calculating the temperature value of the object (equation in fig. 8).

5. Preliminary results

The first results in the form of IR images are presented in fig. 9. We noticed that the developed system allowed one to measure the temperature above 250-300°C. The images in fig. 9 were obtained with the fixed integration time. In addition, we could not get the signal below 300°C due to a relatively high noise. Another problem is the influence of the emissivity and ambient radiation on the temperature measurement. One should bear in mind that emissivity varies with temperature. All these measurement problems render the calibration process very important.





To confirm the correctness of the calibration performed, measurements of the temperature value in dynamic conditions during forced cooling of the reference object in a temperature range of $500^{\circ}C - 250^{\circ}C$ were made. The studies were carried out in a dark room. The emissivity value of the reference object, determined previously, was taken into account – Table 2. During the measurement the integration time was automatically adjusted to the magnitude of radiation intensity of the object so as to avoid saturation of camera sensors. The result of the camera signal is presented in digital units *DL* in fig. 10. Then, the *DL* values were converted to temperature values according to calibration curve. At the same time, the temperature value was measured by means of an *MWIR* infrared camera. The results of temperature measurement with both *NIR* and *MWIR* cameras are presented in fig. 11.

The final experiment made at this stage of the research concerned the measurement of the tip of the soldering tool – fig. 12. It was measured in the steady state using two systems for comparison: calibrated *NIR* and *MWIR* ones. The results were very coincident. The temperature of the tip was about 400°C, and the disparity between the measurements made with *NIR* and *MWIR* were about 2°C, i.e. 0.5%.

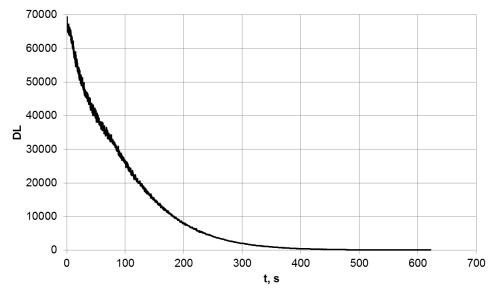


Fig.10. Curve of cooling of the reference object, camera signal in DL units

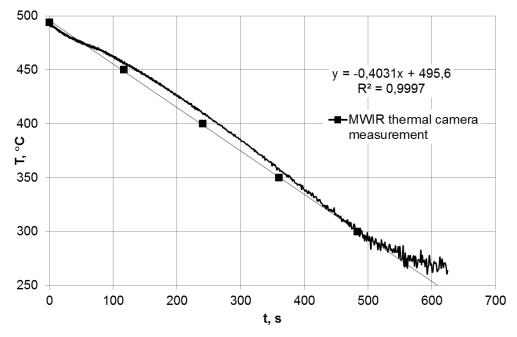


Fig. 11. Curve of cooling of the reference object, temperature in $^\circ\text{C}$

In Table 3 the results of temperature measurement and their relative error are presented. As can be seen, the error does not exceed 2.5%.

Ē	Temperature value measured	Temperature value measured with	Relative error, %
	with NIR camera, °C	MWIR camera, °C	
	492.27	494	-0.35
Ē	456.39	450	1.42
Ē	409.20	400	2.30
Ē	358.15	350	2.33
Γ	301.52	300	0.51

Table 3. Comparison of temperature values measured with NIR and MWIR cameras

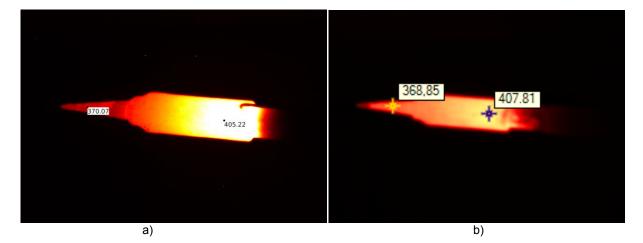


Fig. 12. IR images of a soldering tool taken with the CCD-NIR camera (a) and MWIR thermal camera (b)

6. Conclusions

On the basis of the research carried out, the following comments and conclusions can be presented:

10.21611/qirt.2016.149

- The application of dynamic correction of the integration time allows considerable extension of measurement range of the camera. Due to the linear relationship between the camera signal and the integration time, this correction can also be based on linear relationships. Without the adjustment of the integration time, the measurement would only be possible within a very small range of changes in the temperature value of the object under study.
- A calibration curve (in the work logarithmic approximation was used) can be determined on the basis of a number of
 measurement points, positioned mainly at a lower range of the temperatures measured, e.g. which, in the present
 work, ranged from 250 to 500°C. In the absence of a black body for the *NIR* range analysed, it is possible to
 perform calibration e.g. using a black body for the medium wavelength infrared (*MWIR*).
- In the NIR range analysed, it is necessary to take into consideration the effect of emissivity of both the reference
 object used in the calibration process and the object studied during temperature measurement. To do so, a mirror
 for the near infrared spectrum (polished copper sheet).

In the present paper, preliminary results of the temperature measurement accuracy by the method of analysis of radiation in the *NIR* range have been presented and evaluated. For the evaluation of accuracy the simultaneous measurement of the temperature value in the *NIR* and *MWIR* range by means of an infrared camera.

Acknowledgment

This work was supported by the Polish National Centre for Research and Development (NCBiR) under Project PBS1/A4/2/2012

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